

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|--------------|--------------------------------------------|-------------|------------------|
| Applicant : | Hongyong Zhang | Art Unit : | 2814 |
| Serial No. : | 09/362,808 | Examiner : | Shrinivas H. Rao |
| Filed : | July 28, 1999 | Conf. No. : | 7320 |
| Title : | METHOD OF FABRICATING SEMICONDUCTOR DEVICE | | |

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant requests consideration of the reference listed on the attached PTO-1449 form.

This statement is being filed before the receipt of a first Office Action on the merits after the filing of a RCE. Please apply any charges or credits to Deposit Account No. 06-1050.


Respectfully submitted,

Date: March 14, 2008

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